

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

#2/A  
KD

APPLICANT: Hiroki Kikuchi

ATTORNEY DOCKET NO:

09792909-5025

SERIAL NO.

## GROUP ART UNIT:

FILING DATE:

**EXAMINER:**

**INVENTION:** "FOCUSING CONTROL MECHANISM, AND INSPECTION APPARATUS USING SAME"

## **PRELIMINARY AMENDMENT**

Asst. Commissioner of Patents  
Washington, D.C. 20231

Sir:

Please add the following at page 1 between the title and the heading “Background of the Invention.”

--RELATED APPLICATION DATA

The present application claims priority to Japanese Application No. P2000-155403 filed May 25, 2000 which application is incorporated herein by reference to the extent permitted by law.--

Respectfully submitted,

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